

## FEE TRANSMITTAL

Electronic Version v08

Stylesheet Version v08.0

**Title of  
Invention**

Methods of Treating a Silicon Carbide Substrate for Improved Epitaxial Deposition  
and Resulting Structures and Devices

Application Number :

Date :

First Named Applicant: Davis Andrew McClure

Attorney Docket Number: 5000.238A

**TOTAL FEE AUTHORIZED \$ 1608**

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as large entity

**BASIC FILING FEE**

Fee Description	Fee Code	Amount \$	Fee Paid \$
Utility Filing Fee	1001	770	770
Subtotal For Basic Filing Fees: \$ 770			

**EXTRA CLAIM FEES**

Fee Description	Extra Claim	Fee Code	Amount \$	Fee Paid \$
Total Claims : 57	37	1202	18	666
Independent Claims : 5	2	1201	86	172
Subtotal For Extra Claims Fees: \$ 838				

**AUTHORIZED BILLING INFORMATION**

**The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:**

Credit account number: 1001  
Expiration Date (YYYYMMDD): 2004-07-31  
Authorized name: Philip Summa  
Billing address: 28277